



500.42015VX1

Applicants: MIYA et al  
Serial No.: 10/781,689  
Filed: February 20, 2004  
For: Diagnosis Method For Semiconductor Processing Apparatus  
Group: 1763  
Examiner: P. Hassanzadeh

CITATION OF DOCUMENTS UNDER 37 CFR 1.56

Mail Stop: DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 14, 2005

Sir:

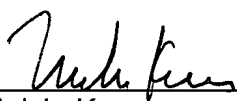
In the matter of the above-identified application, applicants are submitting herewith copies of the non-US documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

It is respectfully requested that these documents be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus Deposit Account No. 01-2135 (Case: 500.42015VX1), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

  
\_\_\_\_\_  
Melvin Kraus  
Registration No. 22,466

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Attachments

Form PTO-1449  
EquivalentU.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DKT. NO.  
500.42015VX1SERIAL NO.  
10/781,689INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT

(Use several sheets if necessary)

## APPLICANT

MIYA et al

## FILING DATE

February 20, 2004

## GROUP

1763

## U.S. PATENT DOCUMENTS

Ex. Initial	Doc. No.	Date	Name	Class	Subclass	Filing Date
AA						
AB						
AC						
AD						
AE						
AF						
AG						
AH						

## U.S. PATENT APPLICATIONS

	Publication Number	Name	Publication Date
AI			
AJ			
AK			
AL			

## FOREIGN PATENT DOCUMENTS

	Doc. No.	Date	Country	Class	Subclass	Translation/Abstract?	
						Yes	No
AM	WO 01/74123	10/01	PCT				
AN	2001-329369	11/01	Japan			Abstract	
AO	9-171992	6/97	Japan			Abstract	
AP	8-213296	8/96	Japan			Abstract	
AQ	2003-100714	4/03	Japan			Abstract	

## OTHER DOCUMENTS

AR	
AS	
AT	

Examiner

Date Considered